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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10036787	FILING DATE 10/19/2001	CLASS 216	SUBCLASS	GAU 1746	EXAMINER <i>Calbert</i>
**APPLICANTS: Toshima Takayuki; Yamasaka Miyako;					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED: <i>RC</i> JAPAN 2000-320646 10/20/2000					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 199372003600	
Verified and Acknowledged Examiners's Initials <i>RC</i>					
TITLE : Method and apparatus of processing surface of substrate					

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

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NOTICE OF ALLOWANCE MAILED		Assistant Examiner		CLAIMS ALLOWED	
				Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner		DRAWING	
Amount Due	Date Paid			Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Applicant's Examiner	
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